

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Paul A. Farrar

Title: METHOD OF CLEANING SEMICONDUCTOR SURFACES

Docket No.: 1303.112US1  
Filed: October 8, 2003  
Examiner: Nicole Blan  
Customer No.: 21186

Serial No.: 10/681,481  
Due Date: June 12, 2009  
Group Art Unit: 1792  
Confirmation No.: 7468

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

We are transmitting herewith the following attached items (as indicated with an "X"):

- ☒ Amendment and Response under 1.111 (8 pgs.)
- ☒ Supplemental Information Disclosure Statement (2 pgs.), Form 1449 (1 pg.)
- ☒ Authorization to charge Deposit Account 19-0743 in the amount of \$180.00 to cover the fee for consideration of Information Disclosure Statement under 97(c).
- ☒ Terminal Disclaimer (3 pgs.)
- ☒ Authorization to charge Deposit Account 19-0743 in the amount of \$140.00 to cover the fee for the Terminal Disclaimer

If not provided for in a separate paper filed herewith, please consider this a PETITION FOR EXTENSION OF TIME for sufficient number of months to enter these papers and please charge any additional fees or credit overpayment to Deposit Account No. 19-0743.

SCHWEGMAN, LUNDBERG & WOESSNER, P.A.

Customer No.: 21186

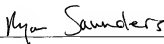
By: 

David C. Peterson

Reg. No. 47,857

CERTIFICATE UNDER 37 CFR 1.8: The undersigned hereby certifies that this correspondence is being filed using the USPTO's electronic filing system EFS-Web, and is addressed to: Mail Stop Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on this 12<sup>th</sup> day of June, 2009.

Name



Signature

